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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/774,362  
Filing Date: February 6, 2004  
Applicant: Yoshihide Matsuo  
Group Art Unit: 2815  
Examiner: WARREN, Matthew E  
Title: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE,  
SEMICONDUCTOR DEVICE,  
AND ELECTRONIC APPARATUS  
Attorney Docket: 9319G-000679

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

SECOND PRELIMINARY AMENDMENT

Sir:

Prior to examination of the present application, please consider the following.

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks** begin on page 4 of this paper.